

INDIANINSTITUTEOFTECHNOLOGYPATNAB IHTAPATNA-801106 RESEARCH&DEVELOPMENT(R&D)UNIT

ADVERTISEMENT NO: R&D/868/BCP/303

DATED: 29/08/2023

PROJECT CODE:R&D/SP/MME/BCP/2023-24/868

Applications are invited in the prescribed format only for the following assignment in a purely time bound research project under taken in this institute.

1. (a)Name of the temporary assignment	:Junior Research Fellow(JRF)
(b) Number of Post	:One
(c) Duration of Post	:36 months
2. Name of the temporary research project	: Mg ₂ TiO ₄ Based Microwave Ceramics: Correlations of Dielectric Properties with Structure, Phase and Sintering Parameters
3. Name of the sponsoringAgency	:Council of Scientific and Industrial Research (CSIR)
4. Fellowship	: Rs. 31000/- per month for first two years + HRA (asapplicable) and Rs. 35000/- per month for the third year + HRA (asapplicable)

5. Qualifications & Experience:

Essential Qualifications:

B.S 4-year programme/ Integrated B.S.-M.S./M.Sc./B.E./B.Tech. or equivalent degree, with 55% marks and passing of NET-LS/GATE test

Desirable Qualifications:

(i) 60 % (or higher) in 10^{th} and 12^{th}

(ii)Bachelor's degree level in the following disciplines:Metallurgical Engineering, Ceramic Engineering/ Technology, Polymer Science/ Chemistry/ Technology, Plastics Science / Technology, Rubber Science / Technology, Mechanical Engineering, Chemical Engineering / Technology, Nanotechnology, Materials Science / Engineering, Physics and Chemistrywith a CGPA 6.5 or 65 %(or higher) and valid GATE (preferably with paper code PH, CY and XE) or NET score (or)

Master's degree level in the following disciplines:Metallurgical Engineering,Ceramic Engineering/ Technology, Polymer Science / Chemistry/ Technology, Plastics Science / Technology, Rubber Science / Technology, Mechanical Engineering, Chemical Engineering / Technology, Nanotechnology, Materials Science / Engineering, Physics, Chemistry, Applied Physics, Solid state Physics/ Technology, Solid State Materials, Solid State Electronic Materials, Applied Chemistry, Nanotechnology, Materials Science/Engineering, Steel Technology, Process Metallurgy, Welding Engineering, Industrial Metallurgy, Surface Science/Engineering, Mechatronics Engineering, Industrial Engineering, Industrial and Production Engineering, Foundry and Forge Technologywith a CGPA of 6.5 or 60 %(or higher) marks for candidate with M.Tech. degree, andCGPA 7.5 or 70%(or higher) for M.Sc.candidate with valid GATE(preferably with paper code PH, CY and XE) or NET score

NOTE:The upper age limit for JRF shall be 28 as on the day on which the application is made. A small relaxation in age limit may be considered, in the case of applicants who are suitably qualified and experienced, on the recommendations of the selection committee. The upper age limit is relaxable upto 5 years in the case of candidates belonging to scheduled castes/ tribes/OBC, women and physically handicapped candidates.



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Interested candidates may send duly filled and scanned copy of the application form (refer to page-3) along with supporting documents (resume, marksheets, certificatesetc) to **Dr. Anirban Chowdhury**, (**Email:anirc@iitp.ac.in**) by email on/before15th September, 2023. Shortlisted candidates (based on their applications) will be intimated for WRITTEN TEST followed by INTERVIEW. The selected candidates would be asked to choose between offline walk-in (no travel allowances (TA) would be provided) and online interview mode.For any query, contact Investigator: Dr.Anirban Chowdhury, Dept. of Metallurgical and Materials Engineering,IIT Patna, Email: anirc@iitp.ac.inTel.: 0612-3028183.

Deputy Registrar

Copy to

- 1. Associate Dean, R&D, IIT Patna
- 2. Advertisement file
- 3. Project file



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ADVERTISEMENT NO: R&D/868/BCP/303 FORMAT OF APPLICATION FOR 'JRF'

DATED: 29/08/2023

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Name&Address Including email id andPhone no. (for Correspondence) NAMEINCAPITAL Address:		Category (GEN/OBC/SC/S T/PD)	DOB dd/mm/yy	Exam.(GA NET,	Professional Exam.(GATE/CSIR- NET,etc)& Validity	
Phone: Email:						
EducationalQualification					A (
Institute/Board		amPassed	assed Yearof Passing % ofMarks/0 PI		ofMarks/C	
		0 th Class				
		2 th Class				
		Tech./B.Sc. requivalent				
		Tech./M.Sc requivalent				
Quelifring Degreed	·····			1		

Qualifying	Degree/major/Specialization
degree	
B.Tech./B.Sc.	
M.Tech./M.Sc.	
Others	

Signature of applicant

Date:
Place: